



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Fre Application of:

RONGHUA WEI ET AL.

Filed:

MARCH 26, 2004

For:

METHOD AND APPARATUS FOR FORMING A NITRIDE LAYER ON A

BIOMEDICAL DEVICE

Serial No.:

10/811,485

**Group Art Unit:** 

1775

Examiner:

DANIEL MILLER

Atty. Dkt.:

SWRI:003 (3020)

Pursuant to 37 C.F.R. 1.8, I certify that this correspondence is being deposited with the U.S. Postal Service in a first class, postage prepaid envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date below:

9//5/C Date

Name

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

## **STATUS INQUIRY**

Pursuant to MPEP § 203.08, Applicant requests the Office to advise the undersigned of the status of this application.

L

Robert M. O'Keefe

Respectfully submitted,

Reg. No. 35,630

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